

# LIST OF ART CITED BY APPLICANT

(PTO-1449)

 ATTY. DOCKET NO.  
YHK-0039

 APPLN. SERIAL NO.  
09/514,250

APPLICANT(S)

Ho Young CHOI

 FILING DATE  
February 28, 2000

 GROUP  
2872

## U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

## U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER'S INITIALS	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	FILING DATE

## U.S. PATENT APPLICATIONS

EXAMINER'S INITIALS	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	FILING DATE

## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	<del>06-331941</del>	<del>12/2/94</del>	<del>JAPAN</del>			X	
	<del>04-361201</del>	<del>12/14/92</del>	<del>JAPAN</del>			X	
	<del>04-214516</del>	<del>8/5/92</del>	<del>JAPAN</del>			X	
	<del>57-108818</del>	<del>7/7/82</del>	<del>JAPAN</del>			X	
	<del>62-278520</del>	<del>12/3/87</del>	<del>JAPAN</del>			X	
	<del>03-276113</del>	<del>12/6/91</del>	<del>JAPAN</del>			X	
	63-155432	6/28/88	JAPAN			X	
	60-247611	12/7/85	JAPAN			X	
	04-361201	12/2/94	JAPAN			X	
	<del>06-331898</del>	<del>12/22/94</del>	<del>JAPAN</del>			X	
	<del>06-347700</del>	<del>12/2/94</del>	<del>JAPAN</del>			X	
	<del>06-331887</del>	<del>9/25/80</del>	<del>JAPAN</del>			X	
	<del>55-124114</del>	<del>2/6/96</del>	<del>JAPAN</del>				X
	<del>08-036131</del>	<del>4/7/88</del>	<del>JAPAN</del>			X	
	63-077003	2/23/84	JAPAN			X	
	02-001109	1/5/90	JAPAN			X	
	59-033636	1/5/90	JAPAN			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

EXAMINER

DATE CONSIDERED

6/13/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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## U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE
<i>me</i>	5,440,429	8/8/1995	Kim			
	<del>5,272,540</del>	<del>12/21/1993</del>	<del>Hirata et al.</del>			

## U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

## U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
<i>me</i>	WO 99/28779	6/10/99	WIPO			X	
<i>me</i>	EP 0 863 440 B1	4/23/2003	EUROPE			X	

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)


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SHEET 1 OF 1

LIST OF PRIOR ART CITED BY  
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H Y ung CHOI t al.

**FILING DATE**  
**February 28, 2000**

GROUP ART UNIT  
2872

## U.S. PATENT DOCUMENTS

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# FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
<i>Ch</i>	98-20576	6/25/98	Korea			X	

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

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June 13/2005

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